

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	((electrical\$3 same conductive same wire) and ((first second) same region) and (diffusion dop\$3 impurity) and (electrical\$3 same conduct\$3 same strap)).clm.	US-PGPU B	OR	ON	2006/09/29 17:46
L2	2	((electrical\$3 same conduct\$3 same wire) and (first second) and (diffusion dop\$3 impurity) and (electrical\$3 same conduct\$3 same strap)).clm.	US-PGPU B	OR	ON	2006/09/29 17:47

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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	416813	conduct\$3 near5 (layer wire film)	US-PGPU B; USPAT; USOCR	OR	ON	2006/09/29 17:40
L2	46773	1 and ((first second) near5 (conductivity dop\$3 diffusion impurity))	US-PGPU B; USPAT; USOCR	OR	ON	2006/09/29 17:40
L4	39919	2 and semiconductor	US-PGPU B; USPAT; USOCR	OR	ON	2006/09/29 17:41
L5	312	4 and (conduct\$4 near5 strap)	US-PGPU B; USPAT; USOCR	OR	ON	2006/09/29 17:41
L7	430421	conduct\$3 same (layer wire film)	FPRS; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2006/09/29 17:40
L8	8727	7 and ((first second) near5 (conductivity dop\$3 diffusion impurity))	FPRS; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2006/09/29 17:40
L9	6883	8 and semiconductor	FPRS; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2006/09/29 17:41
L10	16	9 and (conduct\$4 same strap)	FPRS; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2006/09/29 17:41